

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Akihiko ENDO et al. Group Art Unit : 2891  
Appl. No. : 10/570,669 Examiner : Asak K SARKAR  
Filed : March 6, 2006 Confirmation No. : 1242  
For : SOI WAFER AND ITS MANUFACTURING METHOD

## REQUEST FOR EXTENSION OF TIME

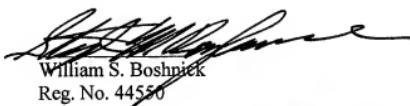
Commissioner for Patents  
U.S. Patent and Trademark Office  
Customer Service Window, Mail Stop Amendment  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir :

A request is hereby made for a one-month extension of time for responding to the Office Action mailed from the U.S. Patent and Trademark Office on October 27, 2008, i.e., from January 27, 2009 to and including February 27, 2009. The fee for a one-month extension of time is being paid concurrently herewith.

The Patent and Trademark Office is hereby authorized to credit any overpayment or charge any additional fee to Deposit Account No. 19-0089.

Respectfully Submitted,  
Akihiko ENDO et al.



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February 20, 2009  
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